

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2335	SERIAL NO. Unknown <i>10/664744</i>
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				FILING DATE Filed Herewith	GROUP Unknown <i>2823</i>

U.S. PATENT DOCUMENTS							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
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FOREIGN PATENT DOCUMENTS							
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					Yes	No	
AJ							
AK							
AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)		
<div style="text-align: center;"> AM </div>	<div style="text-align: center;"> S. Wolf & R. Tauber, SILICON PROCESSING FOR THE VLSI ERA, VOL. 1: PROCESS TECHNOLOGY , pp. 137 and 761-764 (2000). AN AO </div>	

EXAMINER:	DATE CONSIDERED <i>12. 21. 2004</i>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.